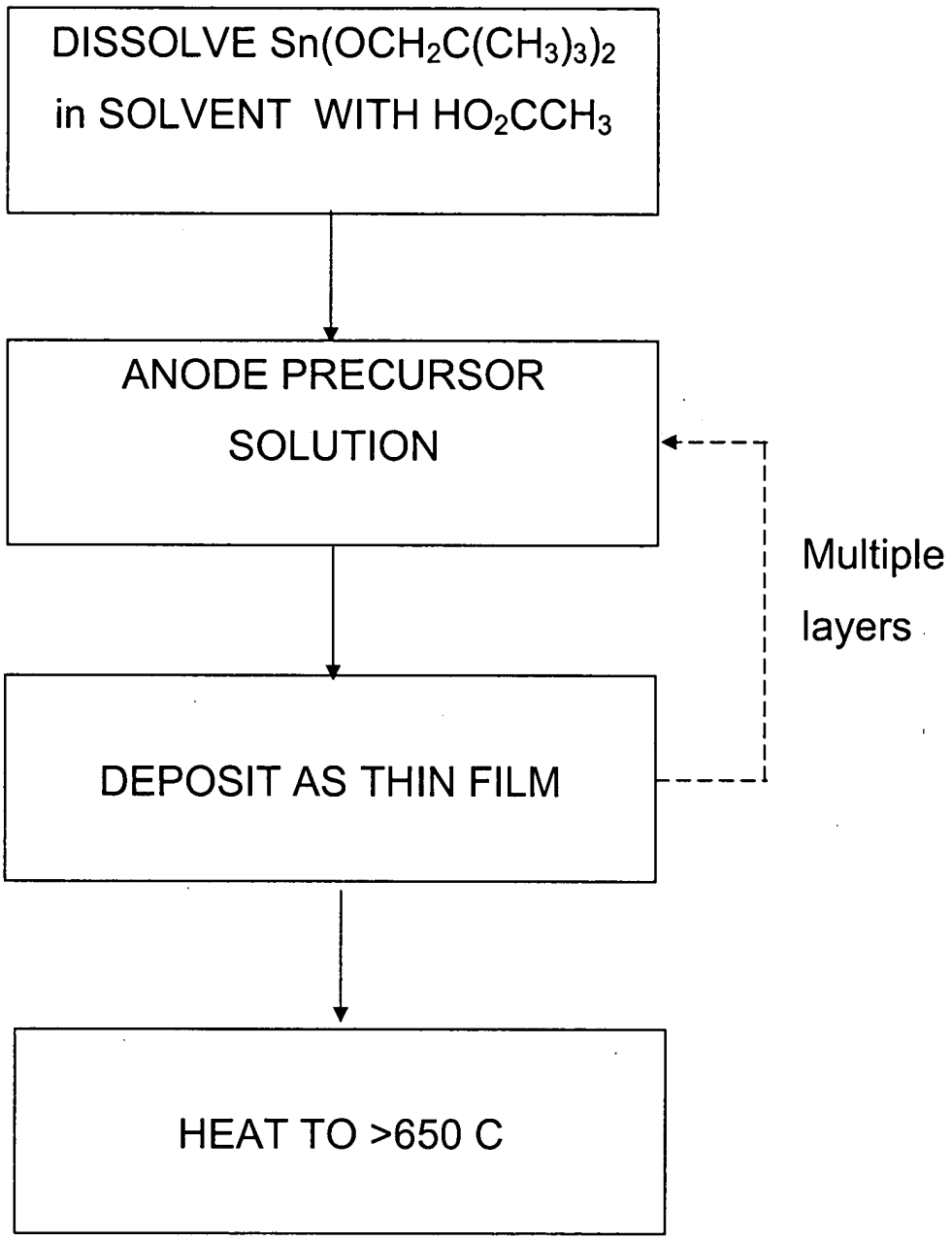

DISSOLVE $Sn(OCH_2C(CH_3)_3)_2$ in SOLVENT WITH HO_2CCH_3
ANODE PRECURSOR SOLUTION
DEPOSIT AS THIN FILM
HEAT TO >650 C
Multiple layers

FIG. 1

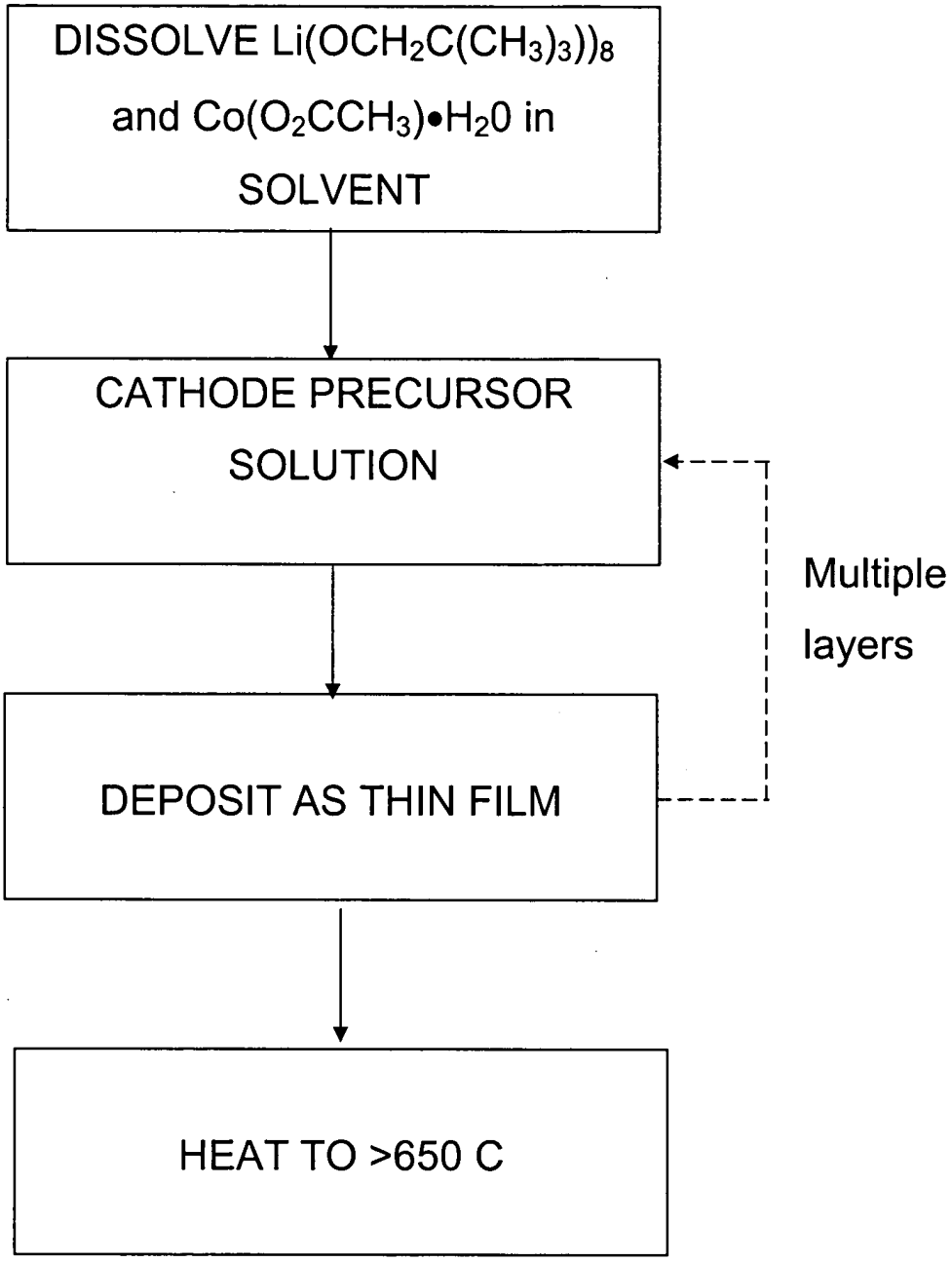
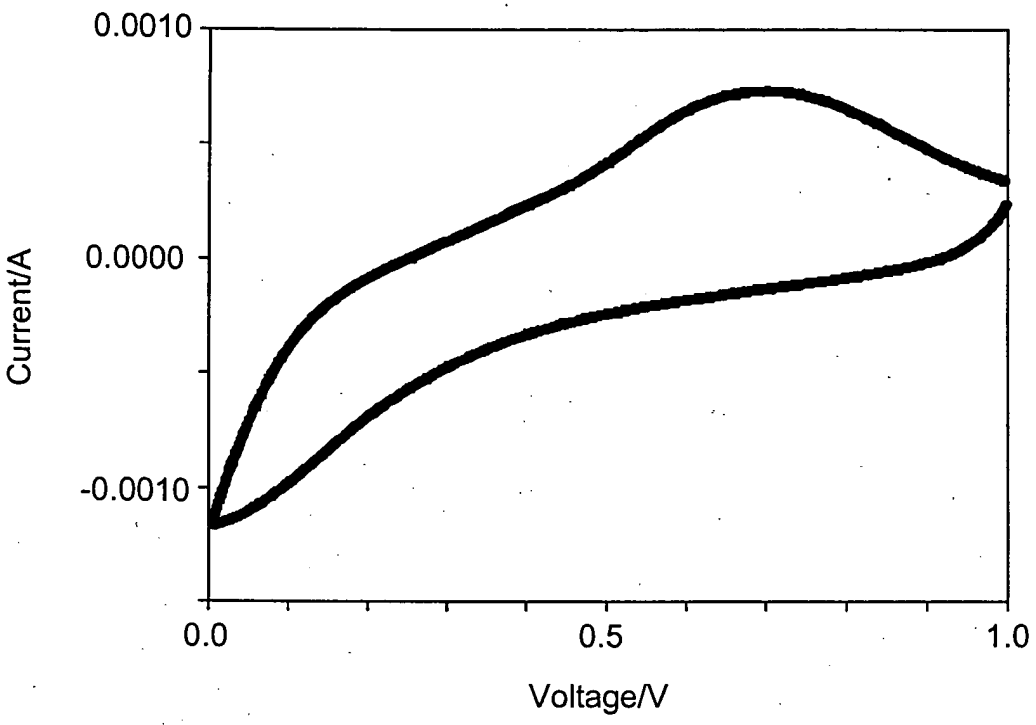

DISSOLVE Li(OCH2C(CH3)3))8 and Co(O2CCH3)•H20 in SOLVENT
CATHODE PRECURSOR SOLUTION
DEPOSIT AS THIN FILM
HEAT TO >650 C
Multiple layers

FIG. 2


0.0010
0.0000
-0.0010
Current/A
0.0
0.5
1.0
Voltage/V

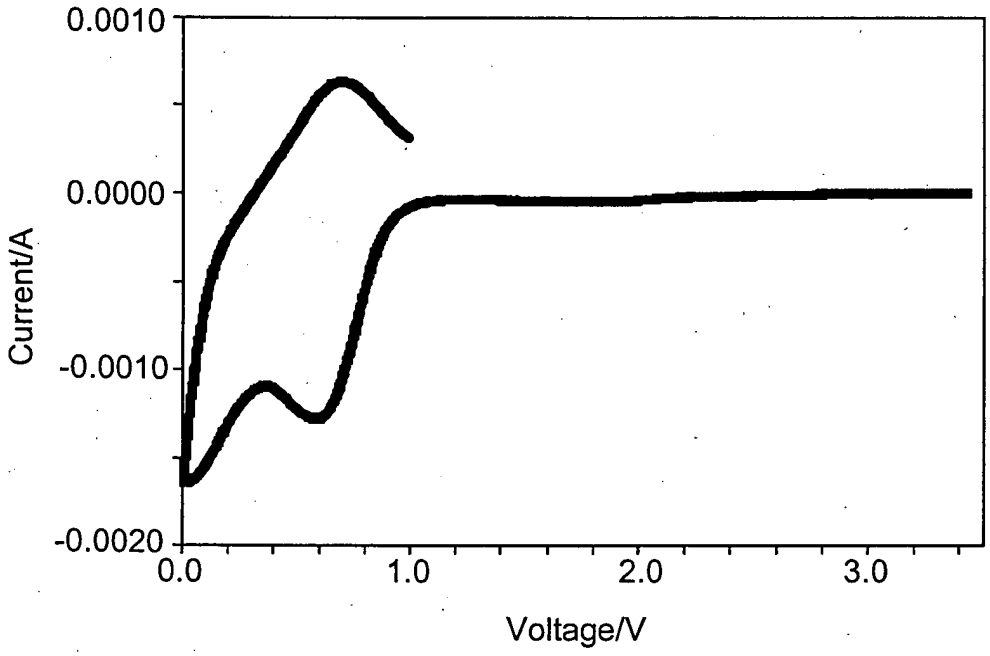

0.0010
0.0000
-0.0010
-0.0020
Current/A
0.0
1.0
2.0
3.0
Voltage/V

FIG. 3

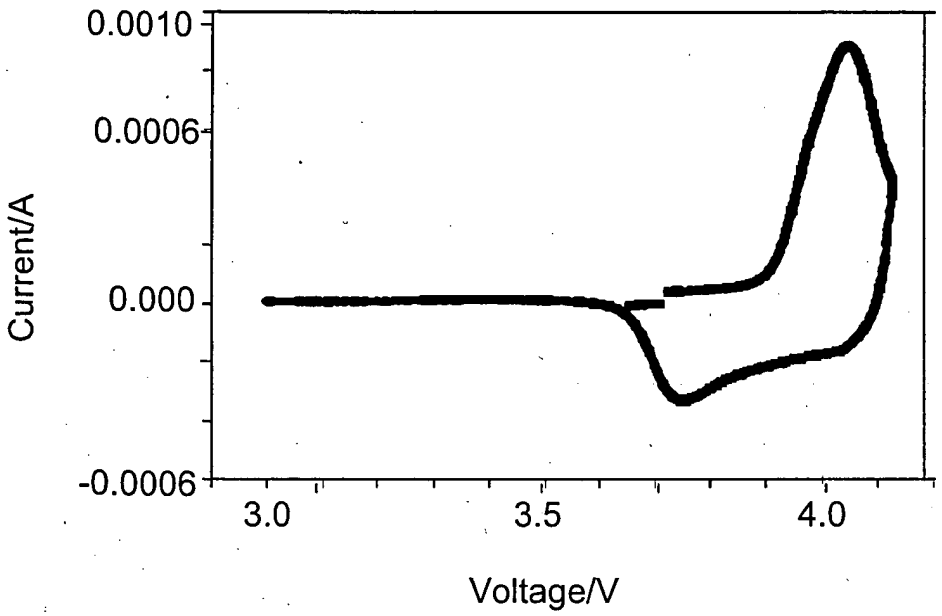


FIG. 4